

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : Pawel DRABAREK
Serial No. : To Be Assigned
Filed : Herewith
For : INTERFEROMETRIC MEASURING DEVICE FOR
DETECTING THE SHAPE OR DISTANCE IN
PARTICULAR OF ROUGH SURFACES

Examiner : To Be Assigned
Art Unit : To Be Assigned

Assistant Commissioner for Patents
Washington, D.C. 20231

PRELIMINARY AMENDMENT

SIR:

Kindly amend the above-identified application before examination, as
set forth below.

IN THE SPECIFICATION:

Please amend the specification as follows.

On page 1, before line 1, insert:

--FIELD OF THE INVENTION--.

On page 1, line 2, change "distance in particular" to --distance, in
particular,--.

On page 1, line 3, change "surfaces, having" to --surfaces. The
interferometric measuring device has--

On page 1, line 7, change "surface, also having" to --surface;--.